



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Naoto Kusumoto et al.                      Art Unit : Unknown  
Serial No. : 10/602,762                                      Examiner : Unknown  
Filed : June 25, 2003  
Title : LASER ANNEALING METHOD

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

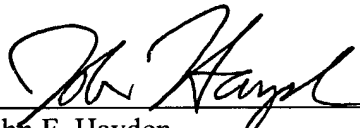
**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Supplemental to an information disclosure statement filed June 25, 2003, Applicants submit the instant information disclosure statement to properly identify a reference earlier cited. Under 35 USC §120, this application relies on the earlier filing date of application serial number 08/594,670, filed on February 2, 1996. The attached Form PTO-1449 lists a reference which was submitted to and/or cited by the Office in the prior application and, therefore, is not provided in this application.

This statement is being filed within three months of filing the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: August 28, 2003

  
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Sheet 1 of 1Substitute Form PTO-1449  
(Transmitted)U.S. Department of Commerce  
Patent and Trademark Office

Attorney's Docket No.

07977-004002

Application No.

10/602,762

**Information Disclosure Statement  
by Applicant**

(Use several sheets if necessary)

(37 CFR §1.98(b))

Applicant

Naoto Kusumoto et al.

Filing Date

June 25, 2003

Group Art Unit

**U.S. Patent Documents**

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						

**Foreign Patent Documents or Published Foreign Patent Applications**

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AJ							
	AK							
	AL							
	AM							
	AN							

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
	AO	Brotherton et al.; "Beam shape effects with EL crystallization of...a-Si"; <i>Solid State Phenomena</i> , Vol. 37-38; pp. 209-304; 1994

Examiner Signature

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Substitute Disclosure Form (PTO-1449)